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AMENDMENT TRANSMITTAL LETTER (Large Entity)

Applicant(s): Chul-Hwan Choi et al.

Docket No.

SEC.890

Application No.
10/050,104Filing Date
01/18/2002Examiner
T. BRAHANCustomer No.
N/AGroup Art Unit
3652Confirmation No.
6556Invention: SELF-CONTAINED SEMICONDUCTOR DEVICE MANUFACTURING EQUIPMENT HAVING
COMPACT ARRANGEMENT OF LOAD-LOCK AND PROCESSING CHAMBERS

JUN 24 2004

COMMISSIONER FOR PATENTS:

Transmitted herewith is an amendment in the above-identified application.

The fee has been calculated and is transmitted as shown below.

CLAIMS AS AMENDED

	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST # PREV. PAID FOR	NUMBER EXTRA CLAIMS PRESENT	RATE	ADDITIONAL FEE
TOTAL CLAIMS	2 -	20 =	0	x \$18.00	\$0.00
INDEP. CLAIMS	1 -	3 =	0	x \$86.00	\$0.00
Multiple Dependent Claims (check if applicable)		<input type="checkbox"/>			\$0.00
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Signature

Dated: JUNE 24, 2004

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Serial No. 10/050,104
SEC.890

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent application of :

Chul-Hwan CHOI et al. : Group Art Unit 3652

Serial No. 10/050,104 : Examiner T. Braham

Filed January 18, 2002 :

**SELF-CONTAINED SEMICONDUCTOR DEVICE MANUFACTURING EQUIPMENT HAVING
COMPACT ARRANGEMENT OF LOAD-LOCK AND PROCESSING CHAMBERS**

AMENDMENT AFTER FINAL UNDER 37 CFR 1.111

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Sir:

In response to the Final Office Action of April 30, 2004, please amend the above-identified application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 4 of this paper.

Remarks/Arguments begin on page 7 of this paper.